

1AP2003030770 24 APR 2006

SHEET 1 OF 1

LIST OF ART CITED BY APPLICANT (PTO-1449)				ATTY. DOCKET NO. K-0793		APPLN. SERIAL NO. 10/54072 NEW U.S. APPLICATION	
				APPLICANT(S) Jee Woong SEOL			
				FILING DATE April 24, 2006		GROUP	
U.S. PATENT DOCUMENTS							
EXAMINER'S INITIALS	*PATENT NO.	*ISSUE DATE	*INVENTOR NAME	CLASS	SUBCLASS	FILING DATE	
/A.R./	5,930,242	7/27/1999	Mimura	370	331	1/15/1997	
U.S. PATENT APPLICATION PUBLICATIONS							
	*PATENT APPLN. PUB. NO.	*PUB. DATE	*APPLICANT	CLASS	SUBCLASS	FILING DATE	
/A.R./	2002/0150064 A1	10/17/2002	Lucidarme	370	333	3/12/2002	
U.S. PATENT APPLICATIONS							
	*APPLN. NO.	*FILING DATE	*INVENTOR	CLASS	SUBCLASS		
FOREIGN PATENT DOCUMENTS							
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
/A.R./	EP0946070	9/29/1999	EUROPE			XX	
/A.R./	EP1146758	10/17/2001	EUROPE			XX	
/A.R./	JP10065612	3/6/1998	JAPAN (Full Japanese Text and English Abst. Only)			XX	
OTHER ART (Including Author, Title, Date, Pertinent Pages, Publisher, Place of Publication, Etc.)							
EXAMINER /Alejandro Rivero/				DATE CONSIDERED 01/11/2008			

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.
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